



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2815
Examiner: Edgardo Ortiz
Confirmation No.: 6303

In Re PATENT APPLICATION OF:

Applicant: Akira Takahashi)
Serial No.: 10/798,482)
Filed: March 12, 2004) AMENDMENT
For: DRY ETCHING METHOD FOR)
SEMICONDUCTOR DEVICE)
Attny Ref.: OKI 414)
July 12, 2005

MAIL STOP AMENDMENT – no fee

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This paper is in response to the Official Action mailed on April 21, 2005. No fee is due. However, please charge our Deposit Account No. 18-0002 if any fees are needed to enter this paper, and please advise us accordingly. It is noted that no petition is required because of the authorization to charge, but please consider this paper a petition for extension of time if needed.

The amendments to the claims are supported in the original disclosure. The word “contiguous” is supported in Fig. 3.

The new specification paragraphs support the particular language of the claim amendments.

New claims 8 and 11 are supported at page 5, line 9, in the specification.